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PROSECUTION OF THE SUBJECT APPLICATION

Applicants: T.L. Ritzdorf et al. Attorney Docket No. SEMT116048  
 Application No.: 09/386,734 Group Art Unit: 1742  
 Filed: August 31, 1999 Examiner: G. Wyszomierski  
 Title: METHOD AND APPARATUS FOR LOW TEMPERATURE ANNEALING  
 OF METALLIZATION MICROSTRUCTURES IN THE PRODUCTION OF A  
 MICROELECTRONIC DEVICE

U.S. PATENT DOCUMENTS

*Examiner Initial	ID	Document No.	Date	Name
<i>Gu</i>	U12	5,277,985	01/11/1994	Li et al.
<i>Gu</i>	U13	5,397,741	03/14/1995	O'Connor et al.
<i>Gu</i>	U14	5,447,599	09/05/1995	Li et al.
<i>Gu</i>	U15	5,707,466	01/13/1998	Atwater et al.
<i>Gu</i>	U16	5,937,142	08/10/1999	Moschi et al.
<i>Gu</i>	U17	5,989,623	11/23/1999	Chen et al.
<i>Gu</i>	U18	6,015,749	01/18/2000	Liu et al.
<i>Gu</i>	U19	6,037,257	03/14/2000	Chiang et al.
<i>Gu</i>	U20	6,066,892	05/23/2000	Ding et al.
<i>Gu</i>	U21	6,121,141	09/19/2000	Woo et al.
<i>Gu</i>	U22	6,123,825	09/26/2000	Uzoh et al.
<i>Gu</i>	U23	6,126,989	10/03/2000	Robinson et al.
<i>Gu</i>	U24	6,139,697	10/31/2000	Chen et al.

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<u>CW</u>	U25	6,184,121 B1	02/06/2001	Buchwalter et al.
<u>CW</u>	U26	6,184,137 B1	02/06/2001	Ding et al.

Examiner

Date Considered

C Wygoniewicz 6/14/01

\*Examiner: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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